PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Keisuke NAMIKI	01/27/2010
Hozumi YASUDA	01/27/2010
Osamu NABEYA	01/27/2010
Makoto FUKUSHIMA	01/28/2010
Shingo TOGASHI	01/28/2010
Satoru YAMAKI	01/28/2010
Katsuhide WATANABE	01/27/2010

RECEIVING PARTY DATA

Name:	EBARA CORPORATION
Street Address:	11-1, Haneda Asahi-cho
City:	Ohta-ku, Tokyo
State/Country:	JAPAN
Postal Code:	144-8510

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	29356456

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER: Q117078

REEL: 024000 FRAME: 0940

PATENT

NAME OF SUBMITTER:	Alan J. Kasper
Total Attachments: 2 source=ASSIGNMENT_AS_FILED#page1.temptors source=ASSIGNMENT_AS_FILED#page2.temptors	

PATENT REEL: 024000 FRAME: 0941

Assignment

Whereas, I/We, <u>Keisuke NAMIKI</u> of <u>c/o EBARA CORPORATION</u>, 11-1, Haneda <u>Asahi-cho</u>, Ohta-ku, Tokyo 144-8510 JAPAN, <u>Hozumi YASUDA</u> of <u>c/o EBARA CORPORATION</u>, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo 144-8510 JAPAN, <u>Osamu NABEYA</u> of <u>c/o EBARA CORPORATION</u>, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo 144-8510 JAPAN, <u>Makoto FUKUSHIMA</u> of <u>c/o EBARA CORPORATION</u>, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo 144-8510 JAPAN, Shingo TOGASHI of <u>c/o EBARA CORPORATION</u>, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo 144-8510 JAPAN, Satoru YAMAKI of <u>c/o EBARA CORPORATION</u>, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo 144-8510 JAPAN and Katsuhide WATANABE of <u>c/o EBARA CORPORATION</u>, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo 144-8510 JAPAN hereinafter called assignor(s), have invented certain improvements in ELASTIC MEMBRANE FOR SEMICONDUCTOR WAFER POLISHING APPARATUS and executed an application for Letters Patent of the United States of America therefor on ; and

Whereas, EBARA CORPORATION of <u>11-1</u>, <u>Haneda Asahi-cho</u>, <u>Ohta-ku</u>, <u>Tokyo 144-8510 JAPAN</u> (assignee), desires to acquire the entire right, title, and interest in the application and invention, and to any United States patents to be obtained therefor;

Now therefore, for valuable consideration, receipt whereof is hereby acknowledged,

I/We, the above named assignor(s), hereby sell, assign and transfer to the above named assignee, its successors and assigns, the entire right, title and interest in the application and the invention disclosed therein for the United States of America, including all divisions, and continuations thereof, and all Letters Patent of the United States that may be granted thereon, and all reissues thereof, including the right to claim priority under 35 U.S.C. §119, and I/we request the Director of the U.S. Patent and Trademark Office to issue any Letters Patent granted upon the invention set forth in the application to the assignee, its successors and assigns; and I/we will execute without further consideration all papers deemed necessary by the assignee in connection with the United States application when called upon to do so by the assignee.

Pennsy	ylvania Avenue, NW,	Washington, DC	2 20037-3213 to insert	here in parentheses
(Appli	cation number 29/35	66,456	and Confirmati	on number
3	3686	_, filed _Febru	arv 25. 2010) the application
numbe	er and filing date of sa	id application wh	nen known.	
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		4		
Date:	Jan. 27, 2010	Keisuke	Namiki	
	s/ Keisuke NAMIKI			
Date:	Jan. 27, 2010	Hozumi	Yasuda	
	,	s/ Hozumi YASUI	DA -	
Date:	Jan. 27. 2010	Samu s/Osamu NABEY	Nabeya	
		s/ Osamu NABEY	A	
Date:	Jan. 28, 2010	Makey	6 Hokushia	
		s/ Makoto FUKUS	SHIMA	

I/We hereby authorize and request our attorneys SUGHRUE MION, PLLC of 2100

PATENT REEL: 024000 FRAME: 0942

Date:	Jan. 28. 20/0	Shingo	Togashi		
		s/Shingo TOGASHI	V		
Date:	Jan. 28, 2010	Satoru	Yamaki		
		s/ Satoru YAMAKI		100	
Date:	Jan. 27. 2010	Fatsuhu	le Watanale		
	•	s/ Katsuhide WATA	NABE		

(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. §261)

PATENT

REEL: 024000 FRAME: 0943